

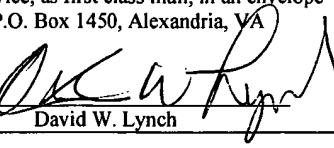


*1/26*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chau, et al      Examiner: Unassigned  
Serial No.: 10/675,126      Group Art Unit: 2652  
Filed: 09/30/03      Docket No.: HITG.053A(0522)  
Title: Method for improving hard bias properties of layers in a magnetoresistive sensor

CERTIFICATE UNDER 37 CFR 18: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 26, 2005.

By:   
David W. Lynch

REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified application to:

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Respectfully submitted,

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By:   
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